



MS AF
PATENT
3430-0175P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Young-Sang BYUN et al. Conf.: 4398
Appl. No.: 10/028,433 Group: 2871
Filed: December 28, 2001 Examiner: T. V. DUONG
For: METHOD OF FORMING A LIQUID CRYSTAL LAYER
USING AN INK JET SYSTEM

Enter Per
RCE
5/11/05
AMS

AMENDMENT UNDER 37 C.F.R. § 1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APRIL 11, 2005

Sir:

In response to the Examiner's final Office Action dated January 11, 2005, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application.

This response includes:

Claim Set as Amended; and
Remarks.